From Eye to Insight



MEETING THE CHALLENGES OF EM SAMPLE PREPARATION

THE LEICA EM SAMPLE PREPARATION PRODUCT PORTFOLIO

Highly comprehensive product portfolio for preparation of biological, medical, and industrial samples.



SAMPLE PREPARATION WITH LEICA MICROSYSTEMS – THE PORTFOLIO THAT GIVES YOU SUCCESS FOR YOUR APPLICATION

| TRIMMING & MECHANICAL PREPARATION | EM TXP, EM RAPID |
|---|---|
| ION BEAM MILLING | EM TIC 3X |
| ULTRAMICROTOMY & CRYO-ULTRAMICROTOMY | EM UC7, ARTOS 3D, EM FC7, EM KMR3 |
| SAMPLE TRANSFER | EM VCT500, EM VCM |
| CLEM & CRYO CLEM | Coral Life Coral Cryo THUNDER Imager EM Cryo CLEM |
| CRYO PREPARATION | EM ICE, EM GP2, EM AFS2, EM CTD |
| COATING & FREEZE FRACTURING | EM ACE200, EM ACE600, EM ACE900 |
| TISSUE PROCESSING | EM TP |
| CONTRASTING | EM AC20 |
| CRITICAL POINT DRYING | EM CPD300 |

FOCUSING ON WORKFLOW SOLUTIONS, WE PROVIDE A PRODUCT RANGE ALIGNED WITH YOUR NEEDS FOR TEM, SEM, CLEM, AND AFM EXPERIMENTS.

Cover images: top: Nematode Eubostrichus dianae with ectosymbiotic bacteria layer, critical point dried with the EM CPD300 (source: Mag. N. Leisch, University of Vienna, Austria); bottom left: Clawed frog (Xenopus laevis), nuclear pores (source: Dr. Martin Goldberg and Christine Richardson, University of Durham, UK); bottom middle: cross section of abrasive paper, prepared with the EM TIC 3X (source: Wolfgang Grünewald, TU Chemnitz, Germany); bottom right: cross-section of a Nb3Sn superconductor, prepared with the EM TIC 3X (source: Wolfang Grünewald, TU Chemnitz, Germany).

TRIMMING & MECHANICAL PREPARATION



EM TXP

EM TXP is Leica's dedicated tool designed for precise mechanical target preparation for a broad range of light and electron microscopy applications.

- Allows for very fine polishing of surfaces, revealing buried features
- designed for precise mechanical target > Accurate preparation of barely visible targets
 - > In-situ stereomicroscope observation



EM RAPID

Advanced specimen trimming device for TEM, SEM, and LM.

- > 0.5, 1, 10, 100 µm step advance
- > Adjustable cutting speed 300-20,000 rpm
- > Advance indication on LCD display

ION BEAM MILLING



EM TIC 3X

The Triple Ion Beam Milling System allows for production of cross sections and planed surfaces for SEM microstructure analysis (EDS, WDS, Auger, EBSD), and AFM investigations.

- > Broad and deep cross sections
- > Uniform, large area milling
- Interchangeable stages: Standard stage, Multiple sample stage, Cooling stage, Rotary stage
- Auger, EBSD), and AFM investigations. > Preserve sample quality by adding EM VCT500 - a versatile vacuum cryo transfer system.



The EM TIC 3X outfitted with an EM VCT500 docking station is the ideal solution for environmentally sensitive and / or cryogenic sample transfer.

SAMPLE TRANSFER





ULTRA MICROTOMY & CRYO-ULTRA MICROTOMY









EM VCT500

Versatile vacuum cryo transfer system for contamination-free transfer of specimens between different preparation and analysis instruments.

EM VCM

EM UC7

EM FC7

contamination-free specimen manipulation.

LN_a cooled workstation for

Ultramicrotome for ultrathin sectioning

of biological and industrial samples.

Low temperature ultrathin

EM VCT500 to transfer environmentally sensitive and / or

Array Tomography solution for

automatic creation and collection of

hundreds of serial-section ribbons ready for SEM array tomography.

cryogenic samples.

ARTOS 3D

cryosectioning of biological and

industrial samples. Can be mounted

The EM FC7 can be outfitted with an

on the EM UC7 and the ARTOS 3D.

> Various specimen holders for SEM, FIB-SEM, freeze-fracture, and more

> From sample loading on, all transfers under vacuum.

> Specimen monitoring throughout workflows.

> Connects workflow steps from sample

> Connects to more than one SEM

preparation to EM

> Improved connectivity given by a movable loading sphere, Crvo-TEM transfer holders, and CLEM adaptors for the THUNDER Imager EM Cryo CLEM and STELLARIS 5/8 Cryo.

> Precision mechanics, ergonomic design, and intuitive User Interface

- > LED light sources provide superior visibility
- > Autotrim mode
- > M80 stereomicroscope with ErgoWedge
- > Temperature range from +110 °C to -185 °C
- > Individual temperature settings for specimen, knife, and gas
- > Easy section collection using micromanipulator and EM CRION ionizer
- > Option to add: EM VCT500 a versatile vacuum cryo transfer system.
- > Fast setup with user pre-defined programs
- > Wrinkle-free sorting and positioning of ribbons on section carrier (ready for SEM imaging)
- > Transparent section carriers available ideal solution for CLEM

EM KMR3

Balanced-break glass knife maker to produce 45° glass knives from 6.4 mm, 8 mm, and 10 mm glass.

- > Highly reproducible, outstanding knife quality
- > Automatic reset of the breaking and scoring mechanism
- > Ergonomic design for comfortable use

CLEM & **CRYO CLEM**

Coral Life

Correlative live-cell and electron microscopy workflow

- > Investigation of dynamic events with nanometer resolution.
- > Combination of fluorescence dynamic data with precisely timed EM analysis.
- > Fast, 3D live-cell imaging for accurate 3D live-cell microscope with incubator, physiological studies SampLink chambers for fast sample > Blur removal for better target identification with
 - THUNDER technology.
 - > Optimized resolution and targeting with a sapphire-corrected objective
 - > Enables capturing of transient events with a transfer time under 5 seconds
 - > Full vitrification of adherent cells
 - > Optimal results with the market-leading solution

| Coral Cryo Correlative 3D cryo light microsco | ppy to support cryo-electron tomography. | Monitoring of cryo sample quality Increased reliability of subsequent cryo- electron tomography steps |
|---|---|--|
| | STELLARIS 5/8 Cryo Confocal cryo light microscope with a dedicated cryo objective and a cryo imaging chamber. | Superresolved images for precise and reliable targeting Monitoring of ice thickness Access to advanced information by fluorescence life time (TauSense). |
| | Cryo Microscopy Kit Cryo transfer shuttle and cryo stage for loading, transfer, and imaging | Full visibility during intuitive loading of grids under gaseous nitrogen. Overpressured stage to avoid contamination |

- > Overpressured stage to avoid contamination
- > Software-embedded temperature control



Coral Cryo Software Tailored software workflow for correlative 3D targeting.

under vitreous conditions.

THUNDER Imager Nano

EM ICE Nano

SampLink chambers.

transfer to the EM ICE Nano, and a sapphire-optimized objective.

High pressure freezing for cryoimmobilization of live cells and optimal

sample fixation. Full compatibility with

- > Innovative, 3D targeting allows for precise positioning of coordinate markers

> User-friendly software workflow

> Data export in open formats

Cryo CLEM

Correlative 2D cryo light microscopy to support cryo-electron tomography and cryo-TEM approaches.



THUNDER Imager EM Cryo CLEM

Camera-based cryo light microscope with a dedicated cryo objective. Imaging chamber and shuttle enable sample quality check and 2D targeting under vitreous conditions.

- > Blur-free, fast cryo imaging (THUNDER technology)
- > Optimal cryo conditions during loading, transfer, and imaging
- Image data and coordinates provided in open > formats for coordinate retrieval in EM

CRYO PREPARATION



EM ICE

High pressure system for freezing

aqueous samples delivers optimal

highest flexibility to meet multiple

EM ICE Electrical Stimulation (ES)

All the features of EM ICE standard,

Automatic plunge freezer for EM grids.

in addition offers fully integrated

electrical stimulation.

EM GP2

sample preservation. Offers the

application demands.









EM AFS2 Freeze substitution and low temperature embedding for light and electron microscopy.



> Retrofitable light and/or electrical stimulation mode

| EM ICE Light Stimulation (LS) | > Software integrated programming for LS |
|---|---|
| All the features of EM ICE standard, | > Automatic recondition of the specific light |
| in addition offers fully integrated light | module |
| stimulation. | > Modules with different LEDs (wave lengths): |
| | UV, blue, red, green, amber |
| | > Detailed log file of each experiment |

- > Light stimulation precision of 1 millisecond
- > Millisecond precision
- > Complete coordination of electrical discharge at the moment of freezing
- > Capturing and imaging action potential and membrane trafficking events
- > Automatic single and multiple sided blotting > Single sided sensor blotting > Fast, easy, and safe filling of the secondary
- cryogen with the unique liquifying head
- > Controllable secondary cryogen temperature
- > Environmental chamber with adjustable temperature and humidity
- > Intuitive control via touch panel
- > Temperature range from -140 °C to +70 °C
- > Transfer function LN, gas regulation in the chamber to minimize contamination
- > LED UV polymerization
- > Stereomicroscope viewing

EM FSP Automatic reagent handling / dispensing system for freeze substitution and PLT.

- > One step preparation
- > Flexible built-in UV light for polymerization
- > Up to 20 samples per run
- > Reduced setup time

EM CTD Cryo tool dryer

- > Combines heated air flow and heating plate for de-icing
- > Maximum temperature +50 °C

COATING & FREEZE FRACTURING



EM ACE200

Desk-top coater for homogeneous coatings of conductive metal or carbon. Fully automated instrument. Options include:

> Carbon thread evaporation

- > Sputtering
- > Both methods with interchangeable heads
- > Quartz crystal measurement
- > Planetary rotation

> Sputtering

> Carbon thread evaporation

> 104 mm automated rotating stage with

> EM VCT500 option for cryo-coating, freezefracture, double-replica, and controlled

> Carbon rod evaporation

> E-beam evaporation

planetary option

environmental transfer

> Glow discharge

- > Glow discharge

EM ACE600

Fully automated, versatile high vacuum coater producing very thin, finegrained, conductive metal and carbon coatings. Up to two angled coating sources configurable. Designed for high resolution analysis, required in FE-SEM and TEM applications.



FM TP

The EM ACE600 outfitted with EM VCT500 is the ideal solution for contamination-free cryo-SEM sample preparation with complete environmental control.

EM ACE900 High-end system for freeze fracture applications. High vacuum, a 3-axis movable microtome, and low angle e-beam coating with rotation ensure the best results for TEM replicas. EM VCT500 option ensures contamination- > EM VCT500 option free cryo-SEM block face imaging.

Automated tissue processor for LM

Automatic contrasting of ultrathin

sections for electron microscopy.

and EM sample preparation.

> Large, closed cryo-shield

- > Rotating cryo stage
- > High resolution low angle e-beam coating of carbon/metal
- > Gate valves for e-beam sources and load lock (sample and knife exchange)

> Programming of all processing steps > Integrated touch-screen-based software

> Consistent, reproducible performance

> 60 runs per one set of Ultrostains

> Low reagent consumption

> Processing of multiple tissues in one run > Environmental conditions maintained during

preparation

> High contrast

TISSUE PROCESSING



CONTRASTING



CRITICAL POINT DRYING



EM CPD300

EM AC20

Critical point dryer for biological (pollen, tissue, plants and insects) and industrial (Micro Electro Mechanical Systems (MEMS), hydro or aerogels) samples.

- > Reduced process times by Leica filler / sample holder concept
- Minimized CO₂ consumption and minimal user > interaction time
- > Integrated waste separator prevents direct contact with chemical waste



WHY LEICA SERVICE?

Enabling your success with complete workflow support

Keep your operations running around the globe with best-in-class services entirely dedicated to microscopy and over 170 years of history.

Key features

- > Leica Team: 500+ Service & Application experts
- > Leica Training: 4-level factory certification program
- > Leica Logistics: 5 regional hubs for genuine parts
- > Leica One Call: PhD-level hotline assistance





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